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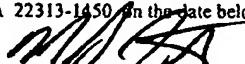
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:  
Fernando Gonzalez et al.  
Serial No.: 10/081,915  
Filed: February 22, 2002  
For: METHOD FOR FORMING  
CONDUCTORS IN A  
SEMICONDUCTOR DEVICE

§ Group Art Unit: 2814  
§  
§ Examiner: Peralta, Ginette  
§  
§ Atty. Docket: MCRO:125--4/FLE  
94-0281.04  
§

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June 6, 2005 Date	 Michael G. Fletcher

**APPEAL BRIEF PURSUANT TO 37 C.F.R. §§ 41.31 AND 41.37**

This Appeal Brief is being filed in furtherance to the Notice of Appeal mailed on April 1, 2005, and received by the Patent Office on April 6, 2005.

1. **REAL PARTY IN INTEREST**

The real party in interest is Micron Technology, Inc., the Assignee of the above-referenced application by virtue of the Assignment recorded at reel 7889, frame 0678, and dated February 23, 1996.